



Inventor: Jeromy M. Eldridge

Title: Perovskite-Type Material Forming Methods, Capacitor Dielectric Forming
Methods, and Capacitor Constructions

Assignee: Micron Technology, Inc.

Docket No.: MI22-2395

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included with the exception of U.S. patents and published U.S. applications (1273 Off. Gaz. Pat. Off. 55, 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 10 Dec 2004

By: James E. Lake
James E. Lake
Reg. No. 44,854

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Form PTO 1449 OFFICE OF THE COMPTROLLER OF PATENTS DEC 10 2004		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2395		SERIAL NO. 10/686,333		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Jerome M. Eldridge				
				ILING DATE October 14, 2003		GROUP 2822		
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,403,441	06/02	Takehiro et al				
	AB	5,953,619	09/99	Miyazawa				
	AC	6,730,575	05/04	Eldridge				
	AD	6,169,688	01/01	Noguchi				
	AE	6,524,651	02/03	Gan et al				
	AF	6,194,753	02/01	Seon et al				
	AG	6,258,608	07/01	Jung				
	AH	6,444,592	09/02	Ballantine				
	AI	6,461,931	10/02	Eldridge				
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ	EP 0727832 A1	08/96	EPO/Miyashita et al				
	AK							
	AL							
	AM							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AN							
	AO							
	AP							
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	AS							
	AT							
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